



P/29-1647 AF ZFW

JUN 12 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Eiji HASEGAWA

Serial No.: 10/768,611

Date: June 8, 2006

Filed: January 29, 2004

Group Art Unit: 2823

For: SEMICONDUCTOR DEVICE WITH NITROGEN IN OXIDE FILM ON
SEMICONDUCTOR SUBSTRATE AND METHOD OF MANUFACTURING
THE SAME

Examiner: Fernando L. TOLEDO

Mail Stop AF
Commissioner for Patent
P.O. Box 1450
Alexandria, VA 22313-1450

**PETITION AND FEE FOR AUTOMATIC EXTENSION OF TIME
UNDER 37 CFR 1.17, 1.136(a) AND 35 USC 41(a)8**

Sir:

Applicant(s) hereby petition(s) the Commissioner for Patents to extend the time for filing a response to the outstanding Office Action by two months. Enclosed is our check No. 24872 which includes the amount of \$450.00 for the petition fee in accordance with 37 CFR 1.17 computed as:

Response within second month
 not small entity (\$450) small entity (\$225)

You are authorized to charge to our Deposit Account No. 15-0700 any additional amounts owing.

If this petition is inadequate to avoid abandonment, the Assistant Commissioner for Patents is petitioned, under 37 C.F.R. §1.136(a), to extend the time by the number of months which will avoid abandonment under 37 C.F.R. §1.135. The fee under 37 C.F.R. § 1.17 should be charged to our Deposit Account No. 15-0700.

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on June 8, 2006

Max Moskowitz

Name of applicant, assignee or
Registered RepresentativeSignature
June 8, 2006

Date of Signature

Respectfully submitted,

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